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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
Joseph Fjelstad :
Application No. 09/732,821 :
Filed: December 8, 2000 :
For: METHODS FOR MANUFACTURING :
RESISTORS USING A :
SACRIFICIAL LAYER :
X

Group Art Unit: 2811
Examiner:
Date: May 21, 2001

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Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Preliminary to initiation of the prosecution of the above-identified pending U.S. patent application, the following amendment and remarks are respectfully submitted.

IN THE SPECIFICATION

CLEAN COPY OF AMENDED SPECIFICATION PARAGRAPH:

a' [0001] The present invention is a continuation-in-part of pending U.S. Patent Application No. 09/409,205 filed September 30, 1999 which is a divisional of pending U.S. Patent Application No. 09/085,352 filed May 27, 1998, which is a continuation of U.S. Patent Application No. 08/634,464 filed April 18, 1996, now U.S. Patent 6,001,671, issued December 14, 1999. The disclosures of said applications are hereby incorporated by reference herein.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class mail in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231 on May 21, 2001.

William Smith

(Signature)

WILLIAM SMITH

Typed or Printed Name of Person Signing Certificate